

INTERNATIONAL SEARCH REPORT

International Application No

PCT/FR2004/050742

A. CLASSIFICATION OF SUBJECT MATTER

IPC 7 H01L21/18

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 H01L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, INSPEC, WPI Data

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 6 274 892 B1 (HOBART KARL ET AL) 14 August 2001 (2001-08-14) column 6, line 66 - column 8, line 4	1-26
A	SHIYANG ZHU ET AL: "Buried cobalt silicide layer under thin silicon film fabricated by wafer bonding and hydrogen-induced delamination techniques" J. ELECTROCHEM. SOC. (USA), JOURNAL OF THE ELECTROCHEMICAL SOCIETY, JULY 1999, ELECTROCHEM. SOC, USA, vol. 146, no. 7, July 1999 (1999-07), pages 2712-2716, XP002291929 ISSN: 0013-4651 page 2712	1,2,5,6, 8,9, 11-14, 20,21, 23,24
A	DE 38 29 906 A (SIEMENS AG) 15 March 1990 (1990-03-15) column 2, line 30 - line 60	1,3

☐ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

* Special categories of cited documents :

- "A" document defining the general state of the art which is not considered to be of particular relevance
- "E" earlier document but published on or after the international filing date
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- "O" document referring to an oral disclosure, use, exhibition or other means
- "P" document published prior to the international filing date but later than the priority date claimed

- "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
- "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
- "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art.
- "&" document member of the same patent family

Date of the actual completion of the international search

25 May 2005

Date of mailing of the international search report

01/06/2005

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Information on patent family members

International Application No

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Patent document cited in search report		Publication date		Patent family member(s)		Publication date
US 6274892	B1	14-08-2001	EP	1062692 A1		27-12-2000
			JP	2002507058 T		05-03-2002
			WO	9946809 A1		16-09-1999
DE 3829906	A	15-03-1990	DE	3829906 A1		15-03-1990